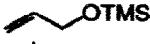
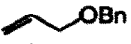




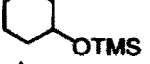
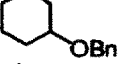
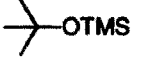
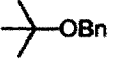
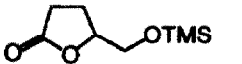
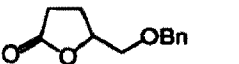
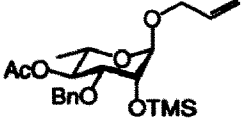
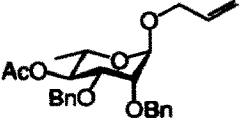


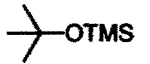
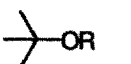
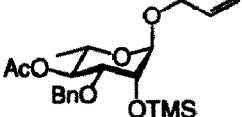
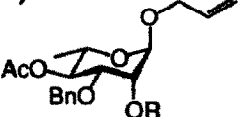
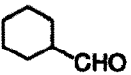
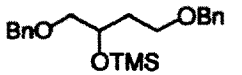
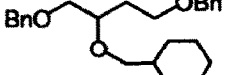
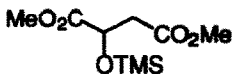
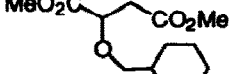




**Table 1. Reductive Etherifications of Aldehydes<sup>a</sup>**

entry	aldehyde	alkoxytrimethylsilane	temp. (°C) <sup>b</sup>	product	yield (%) <sup>c</sup>
1	PhCHO	BnOTMS	-78 → -30	BnOBn	96
2			-30 → 0		99
3			0 → r. t.		81
4			0 → r. t.		92
5			-78 → -30		99
6			0 → r. t.	 (BnOBn)	16 (32)
7			0 → r. t.		89
8			-78 → -30		54 <sup>d</sup> (82) <sup>e</sup> 96 <sup>f</sup>
9		PhOTMS	0 → r. t.	PhOBn (BnOBn)	0 (11)
10	<i>p</i> -NO <sub>2</sub> -C <sub>6</sub> H <sub>4</sub> CHO	<i>n</i> -C <sub>6</sub> H <sub>13</sub> OTMS	0 → r. t.	<i>n</i> -C <sub>6</sub> H <sub>13</sub> OR	88
11			0 → r. t.		73
12			0 → r. t.		63
13			-78 → -30	 (R = <i>p</i> -NO <sub>2</sub> -C <sub>6</sub> H <sub>4</sub> CH <sub>2</sub> -)	52 <sup>f</sup> (89) <sup>e</sup>
14			-30		84
15			-30		36


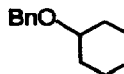
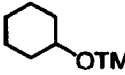
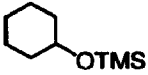
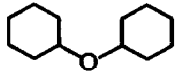
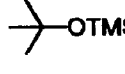
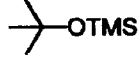
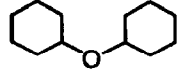
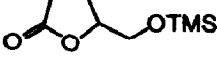
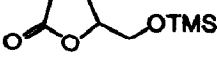
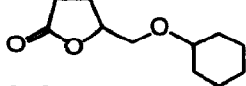

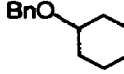

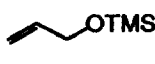
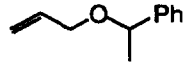

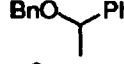

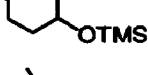
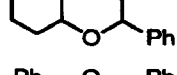

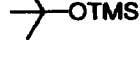
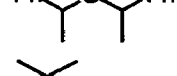
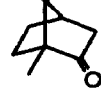
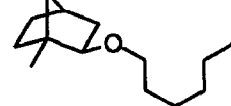
a) The reaction was carried out using aldehyde (1.2 equiv.), alkoxytrimethylsilane (1 equiv.), Et<sub>3</sub>SiH (1.2 equiv.) and TMSOTf (0.1 equiv.) in CH<sub>2</sub>Cl<sub>2</sub> (0.1 M) unless otherwise noted. b) The reaction temperature was warmed up after addition of Et<sub>3</sub>SiH. c) Isolated yield. d) The reaction was carried out using TMSOTf (0.2 equiv.) in toluene. The benzyl ether was obtained in somewhat lower yield under the standard conditions. e) Yield based on consumed starting TMS ether. f) The reaction was carried out using TMSOTf (2 equiv.) and Et<sub>3</sub>SiH (2 equiv.) in toluene.

method can be effectively employed for the protection of alcohols as a benzyl or *p*-nitrobenzyl ether.<sup>9</sup> Entries 7, 8, and 13 show the marked advantage of this protection method in which ester, lactone, and glycosidic acetal

functionalities are unaffected. The following are limitations of the present etherification method. The reactions of silyl ethers of *tert*-butyl alcohol and phenol with benzaldehyde led to poor yields of the corresponding ethers and gave mostly dibenzyl ether through reductive self-etherification of benzaldehyde (entries 6 and 9), although a better result was obtained with *p*-nitrobenzaldehyde (entry 12). This method can not be applicable to the preparation of *p*-methoxybenzyl ethers<sup>10</sup> because of extreme instability of *p*-methoxybenzaldehyde under etherification conditions.

Table 2 shows that reactions of ketones with primary and secondary alkoxytrimethylsilanes again gave the ethers in good to excellent yields. However, in the case of less reactive silyl ether such as *tert*-butoxytrimethylsilane, symmetrical ethers were formed through reductive self-etherification of ketones (entries 3 and 9). It is important to note that, upon reaction of cyclohexenone with benzyloxytrimethylsilane, reduction of the olefinic double bond concomitantly took place to give benzyl cyclohexyl ether (entry 5).

Table 2. Reductive Etherifications of Ketones<sup>a</sup>

entry	ketone	alkoxytrimethylsilane	temp. (°C) <sup>b</sup>	product	yield (%) <sup>c</sup>
1		BnOTMS	-78 → -30		100
2			-78 → -30		95
3			-78 → -30		35
4			0 → r. t.		93
5		BnOTMS	-78 → -30		50
6			-30 → 0		85
7		BnOTMS	-78 → -30		100
8			0 → r. t.		96
9			0 → r. t.		28
10		<i>n</i> -C <sub>6</sub> H <sub>13</sub> OTMS	0 → r. t.		88 <sup>d</sup>

a) The reaction was carried out using ketone (1 equiv.), alkoxytrimethylsilane (1.2 equiv.), Et<sub>3</sub>SiH (1.2 equiv.) and TMSOTf (0.1 equiv.) in CH<sub>2</sub>Cl<sub>2</sub> (0.1 M) unless otherwise noted. b) The reaction temperature was warmed up after addition of Et<sub>3</sub>SiH. c) Isolated yield. d) TMSOTf (1 equiv.) was used.

In conclusion, we have developed a new convenient method with broad applicability for the preparation of ethers, in particular, benzyl ethers under non-basic conditions which is complementary to the conventional Williamson's etherification.

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#### References and Notes

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7. The low yield observed can be attributed to competitive β-elimination reaction.
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